



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **INOUE, et al.**

Group Art Unit: 1763

Serial No.: **08/921,250**

Examiner: **GOUDREAU**

Filed: **August 29, 1997**

P.T.O. Confirmation No.: 9314

For. **FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE LIQUID USED THEREIN**

SUBMISSION OF CORRECTED FORM PTO-1449

Commissioner for Patents
Washington, DC 20231

Date: December 16, 2002

Sir:

A corrected Form PTO-1449 is submitted herewith. More specifically, in the Information Disclosure Statement filed on November 5, 2002, document "AP" was listed by its application number and filing date. As such, the attached Form PTO-1449 corrects the information of document "AP" so that it reflects the publication number and publication date.

In the event that any fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

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